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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of

Confirmation No.: 4349

OGATA

Atty. Ref.: 461-72

Serial No. 09/931,908

Group: 1751

Filed: August 20, 2001

Examiner: Ogata et al

For: THERMISTOR DEVICE, THERMISTOR DEVICE MANUFACTURING METHOD  
AND TEMPERATURE SENSOR

\* \* \* \* \*

March 3, 2004

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**STATEMENT**

Pursuant to the requirement of the Interview Summary of February 3, 2004, which was received February 12, 2004, the undersigned states that the Interview Summary is accurate in its brief description of the issues discussed with the Examiner during the interview of February 3, 2004. Nothing further is believed to be required in response to the Interview Summary however the Office is requested to contact the undersigned if otherwise.

Respectfully submitted,

**NIXON & VANDERHYTE P.C.**

By: \_\_\_\_\_

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